

#3 D Dwy
7/31/01

FORM PTO-1449		Atty. Docket No.: 1100.1116101 (H16-26635)	Serial No.: 09/749,171
<p>LIST OF PATENTS AND PUBLICATIONS FOR APPLICANT'S INFORMATION DISCLOSURE STATEMENT</p> <p><i>O I P E</i></p> <p>MAY 29 2001</p> <p>PATENT & TRADEMARK OFFICE</p>		Applicant:	
		Cabuz et al.	
		Filing Date	Group Art 1 MAY 31 2001 1765
		12/27/2000	TC 1700

U.S. PATENT DOCUMENTS

Examiner Initial	Document No.	Date	Name	Class	Sub Class	Filing Date If Appropriate
AA	6,190,571	02/20/2001	Kato	216	2	
AB	6,125,700	10/03/2000	Tsugai et al.	73	504.12	
AC	6,092,417	07/25/2000	Yamamoto	73	504.04	
AD	6,089,089	07/18/2000	Hsu	73	504.12	
AE	6,089,088	07/18/2000	Charvet	73	504.12	
AF	6,087,747	07/11/2000	Dhuler et al.	310	90	
AG	6,067,858	05/30/2000	Clark et al.	73	504.16	
AH	5,992,233	11/30/1999	Clark	73	514.35	
AI	5,969,250	10/19/1999	Greiff	73	514.38	
AJ	5,914,801	06/22/1999	Dhuler et al.	359	230	
AK	5,894,090	04/13/1999	Tang et al.	73	504.02	
AL	5,880,368	03/09/1999	FritzPatrick	73	493	
AM	5,869,760	02/09/1999	Geen	73	504.12	
AN	5,817,942	10/06/1998	Greiff	73	514.01	
AO	5,757,103	05/26/1998	Lee et al.	310	309	
AP	5,646,348	07/08/1997	Greiff et al.	73	514.36	
AQ	5,492,596	02/20/1996	Cho	156	632.1	
AR	5,490,420	02/13/1996	Burdess	73	504.02	
AS	5,329,815	07/19/1994	Dunn et al.	73	505	
AT	5,313,835	05/24/1994	Dunn	73	505	
AU	4,654,663	03/31/1987	Alsenz et al.	340	870.3	
AV	09/748,488		Cabuz et al.			12/27/2000

EXAMINER:

DATE CONSIDERED:

1/9/02

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

FORM PTO-1449		Atty. Docket No.: 1100.1116101 (H16-26635)	Serial No.: 09/749,171
<p style="text-align: center;">LIST OF PATENTS AND PUBLICATIONS FOR APPLICANT'S INFORMATION DISCLOSURE STATEMENT</p> <p style="text-align: center;">MAY 29 2001</p> <p style="text-align: center;">PATENT & TRADEMARK OFFICE</p>		Applicant:	
		Cabuz et al.	
		Filing Date	Group Art:
		12/27/2000	1765

FOREIGN PATENT DOCUMENTS

		Document No.	Date	Country	Class	SAY Class	RECEIVED MAY 31 2001 TC 1700	Translation Yes No
	AW							
	AX							

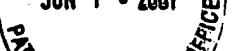
OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)

AY	J. Bernstein et al., "A Micromachined Comb-Drive Tuning Fork Rate Gyroscope," <u>Digest of IEEE/ASME MEMS Workshop</u> , pp. 143-148 (February 1993)
AZ	W. A. Clark et al., "Surface Micromachined X-Axis Vibratory Rate Gyroscope," <u>Proceedings of Solid State Sensor and Actuator Workshop</u> , pp. 283-287 (June 2-6, 1996)
BA	Dave Van Domelen, "The Coriolis Effect," <u>http://www.physics.ohio-state.edu/~dvandom/Edu/coriolis.html</u> , pp. 1-3 (1996)
BB	"Coriolis Effect," <u>http://zebu.uoregon.edu/~js/glossary/coriolis_effect.html</u> (dated on or before 12/27/2000)

EXAMINER:

DATE CONSIDERED:

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

FORM PTO-1449 	Atty. Docket No.: 1100.1116101 (H16-26635)	Serial No.: 09/749,171
<p style="text-align: center;">LIST OF PATENTS AND PUBLICATIONS FOR APPLICANT'S INFORMATION DISCLOSURE STATEMENT</p>	Applicant:	
	Cabuz et al.	
	Filing Date	Group Art:
	12/27/2000	1765

U.S. PATENT DOCUMENTS

FOREIGN PATENT DOCUMENTS

		Document No.	Date	Country	Class	Sub Class	^{BOOK} Translation Yes <input checked="" type="checkbox"/> No <input type="checkbox"/>

OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)

 AA	Thesis by William Clark, University of Berkley, "Micro Machined Vibratory Rate Gyroscopes", 1997, pp. 14-21.
 AB	Y.B. Gianchandani et al., "A Bulk Silicon Dissolved Wafer Process for Microelectromechanical Devices", Journal of Microelectromechanical Systems, Vol. 1, No. 2, June 1992, pp. 77-85.

EXAMINER:

DATE CONSIDERED:

~~EXAMINER:~~ Initial if citation considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.